

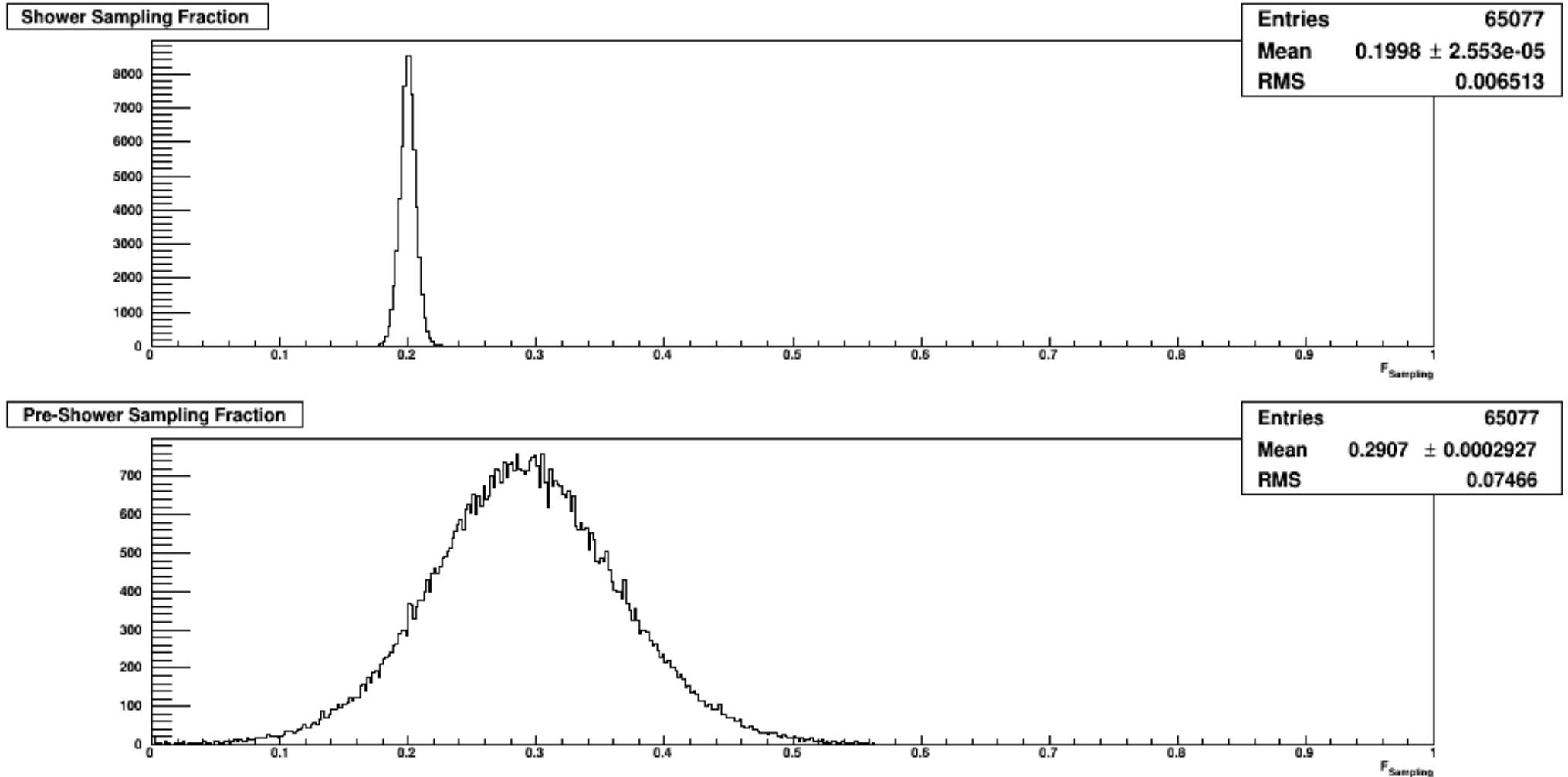
ECAL Summary 8

ECAL Update

Update

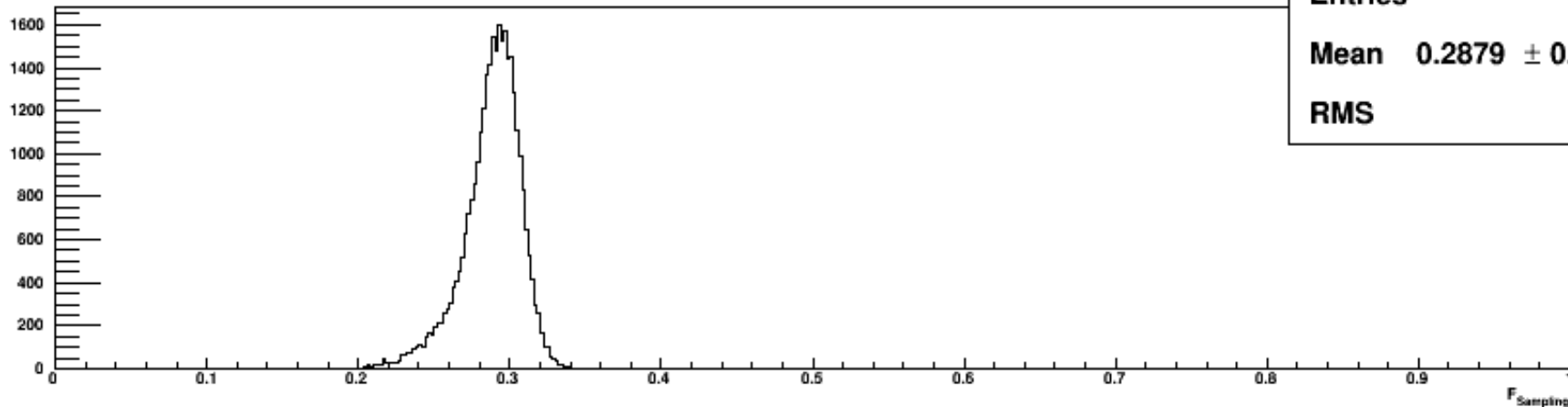
- Compare sampling fractions between 10 – 11 GeV muons and 2-4 GeV electrons
 - High energy muons produce less soft-energy charge particles (due to the EM shower)
 - Act as MIP
 - Electrons deposit energy mainly by EM shower
- Compare energy deposited only from muons to understand ECAL energy deposit

Electrons: Sampling Fraction $F_s(\text{edep})$



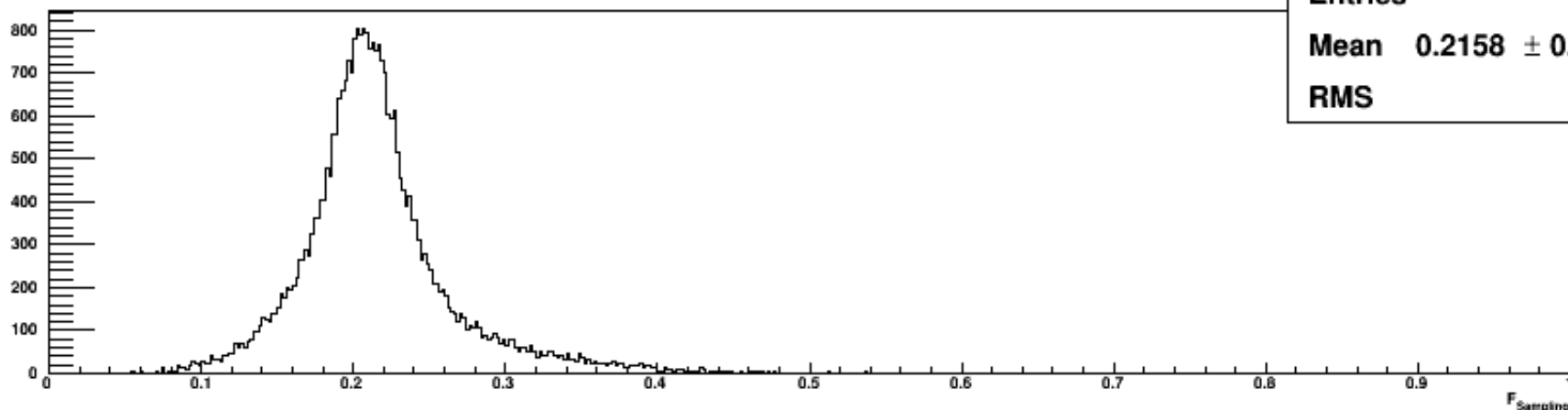
Muons : Sampling Fraction $F_s(\text{edep})$

Shower Sampling Fraction



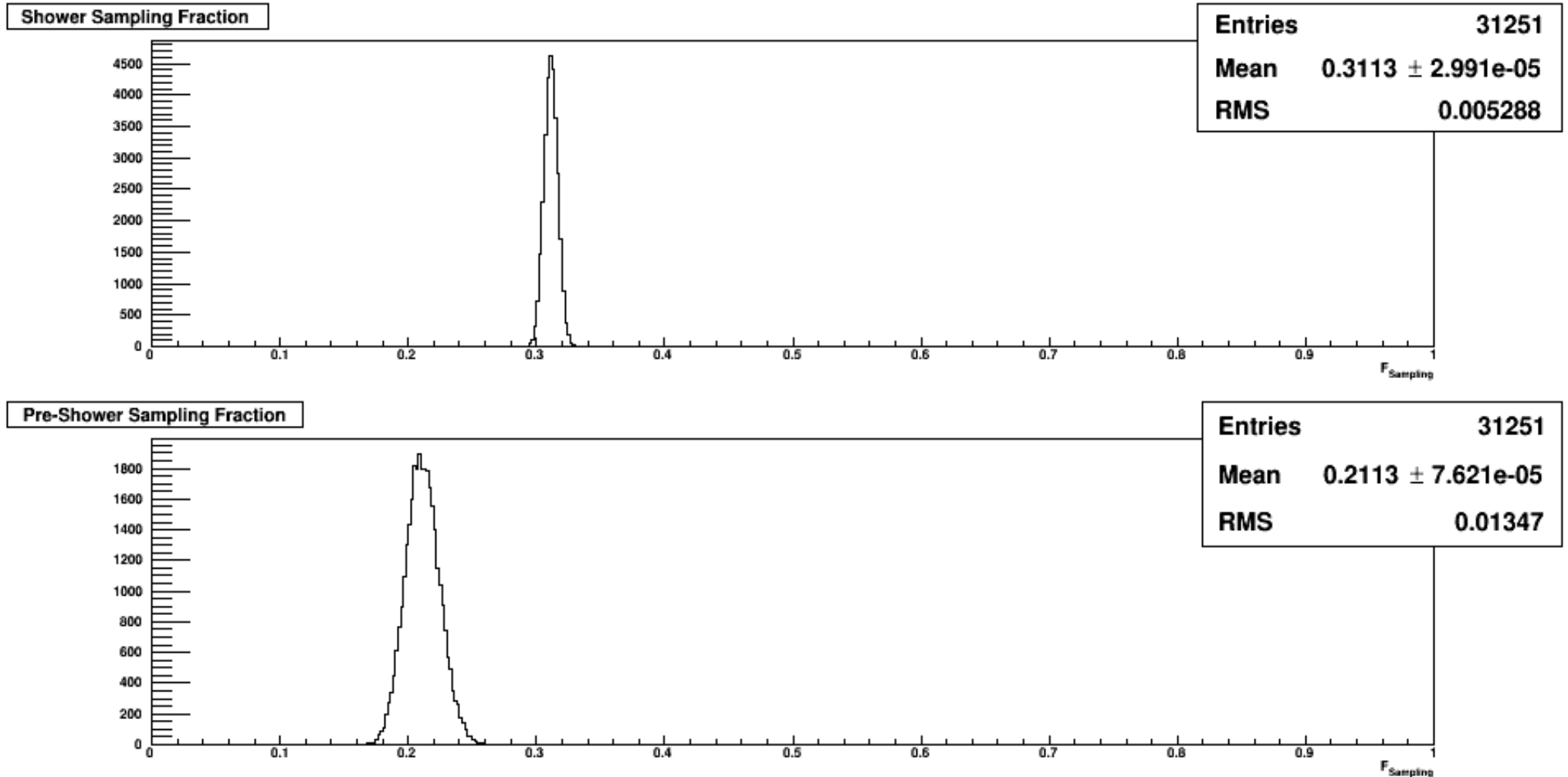
Entries	31251
Mean	0.2879 ± 0.0001079
RMS	0.01907

Pre-Shower Sampling Fraction



Entries	31251
Mean	0.2158 ± 0.0002876
RMS	0.05083

Only Edep from Muons : Sampling Fraction $F_s(\text{edep})$



Sampling fraction for MIP type energy loss in the material

- The sampling fraction for MIP

$$\frac{2 \text{ MeV/cm} \times 0.15 \text{ cm}}{(2 \text{ MeV/cm} \times 0.15 \text{ cm} + 12.8 \text{ MeV/cm} \times 0.05 \text{ cm})} = 0.319$$

- This agrees with what we see from Muon simulations

Lead $dE/dx|_{\min} = 1.123 \text{ MeV.cm}^2/\text{g}$ and density is 11.4 g/cm^3
 Scint $dE/dx|_{\min} = 1.936 \text{ MeV.cm}^2/\text{g}$ and density is 1.03 g/cm^3
 Lead $dE/dx|_{\min} = 12.8 \text{ MeV/cm}$ and layer thickness is 0.05 cm
 Scintillator $dE/dx|_{\min} = 2 \text{ MeV/cm}$ and layer thickness is 0.15 cm

Material	Z	A	Z/A	$dE/dx \text{ min}$ ($\text{MeV.cm}^2/\text{g}$)	Density (g/cm^3)
H ₂ (liquid)	1	1.008	0.992	4.034	0.0708
He	2	4.002	0.500	1.937	0.125
C	6	12.01	0.500	1.745	2.27
Al	13	26.98	0.482	1.615	2.70
Cu	29	63.55	0.456	1.403	8.96
Pb	82	207.2	0.396	1.123	11.4
W	74	183.8	0.403	1.145	19.3
U	92	238.0	0.387	1.082	19.0
Scint.			0.538	1.936	1.03
BGO			0.421	1.251	7.10
CsI			0.416	1.243	4.53
NaI			0.427	1.305	3.67

Sampling fraction MIP vs. EDEP

- From electron simulation, we see that sampling fraction $F_s(\text{edep})$ is significantly smaller than $F_s(\text{MIP})$
 - $F_s(\text{edep})/F_s(\text{MIP}) \sim 0.64 \rightarrow e^-/\text{mip}$ ratio
- The dominant part of the electron edep in the scintillator is not produced by minimum ionizing particles (MIP), but rather by the EM shower (low-energy electrons/positrons) reaching the scintillator